

Docket No.: 265523US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION: Haruhiko FURUYA, et al.

SERIAL NO.: 10/523,974

GAU: 2823

FILED: February 8, 2005

EXAMINER: MALDONADO, J.

FOR: SEMICONDUCTOR PROCESSING METHOD AND APPARATUS FOR PROCESSING
TARGET SUBSTRATE

LETTER SUBMITTING REPLACEMENT DRAWING SHEET(S)

COMMISSIONER FOR PATENTS
Alexandria, VA 22313

SIR:

Responsive to the below indicated communication, the following drawing sheets are submitted herewith:

☒ 1 Replacement Drawing Sheets

☐ _____ New Drawing Sheets

☒ Official Action dated July 2, 2007

☐ Notice of Allowance/Issue Fee dated _____

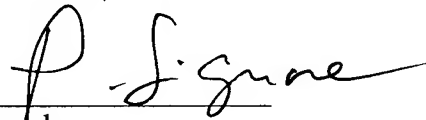
☐ Other dated _____

The changes and/or modifications made include the following:

The attached sheet of drawings includes changes to Fig. 7. This sheet, which includes Fig. 7, replaces the original sheet including Fig. 7.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



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